

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

APPLICANT: Tomoyuki Hirano, et al. ATTY. DOCKET NO. 09792909-5225

SERIAL NO.

DATE FILED:

INVENTION: "METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE"

Assistant Commissioner of Patents
Washington, D.C. 20231

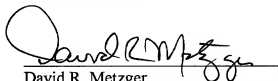
S I R:

Between the title and the heading "Background of the Invention" on page 1, insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application(s) No(s). P2000-319402 filed October 19, 2000, which application(s) is/are incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

 (Reg. No. 32,919)

David R. Metzger
SONNENSCHN NATH & ROSENTHAL
P.O. Box #061080
Wacker Drive Station
Sears Tower
Chicago, IL 60606-1080
Customer #26263

Attorneys for Applicant(s)